

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of:	Examiner: Kim, Jung W.
Hidema Tanaka, et al.	Group Art Unit: 2132
Serial No.: 10/762,654	
Filed: January 21, 2005	
For: CIPHER STRENGTH EVALUATION APPARATUS	September 19, 2007
	Costa Mesa, California 92626

**RESPONSE TO OFFICE ACTION**

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

In response to the Office Action of June 20, 2007, please amend the above-identified application as follows: